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Docket: 0756-1974



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL Application of )  
Yasuhiko TAKEMURA et al. )  
Based On Serial No. 08/853,187 ) Art Unit: 2822  
Which Was Filed: April 29, 1997 ) Examiner: M. Wilczewski  
For: SEMICONDUCTOR DEVICE AND )  
PROCESS FOR FABRICATING )  
THE SAME ) Date: May 27, 1999

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 08/853,187 filed April 29, 1997, and the

predecessor applications including U.S. Patent Nos. 5,661,311 and 5,569,935.

Respectfully submitted,



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